## Applicant(s)/Patent Under Reexamination Application/Control No. 09/558,922 KEMBEL ET AL Notice of References Cited Art Unit Examiner Page 1 of 1 2176 Chau Nguyen **U.S. PATENT DOCUMENTS** Date **Document Number** Classification Name Country Code-Number-Kind Code MM-YYYY 07-2002 HUANG et al. 707/10 US-2002/0091697 Α Ferrel et al. 715/522 В US-6,199,082 03-2001 709/219 US-6,594,682 07-2003 Peterson et al. С US-D US-Ε US-F US-G USн USt US-J US-K US-L US-М **FOREIGN PATENT DOCUMENTS** Date **Document Number** Classification Name Country Country Code-Number-Kind Code MM-YYYY Ν 0 Ρ Q R s Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U ٧ W Х

A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.